

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Appl. No.	<b>To Be Assigned</b>	Confirmation No.: <b>TBA</b>
Applicant(s):	<b>UCHIDA, Maki</b>	
Filed:	<b>Concurrent Herewith</b>	
TC/A.U.	<b>To Be Assigned</b>	
Examiner:	<b>To Be Assigned</b>	
Title:	<b>Electrophotosensitive Material and Method of Producing the Same</b>	

Docket No.: **032739.0651**  
Customer No.: **25461**

**CLAIM FOR FOREIGN PRIORITY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Relating to the above-identified United States patent application, and under the provisions of Section 119 of 35 U.S.C., Applicant hereby claims the benefit of Japanese Patent Application No. 2000-326518 filed in Japan on October 26, 2000.

In support of Applicant's claim for priority, a certified copy of said Japanese application was submitted for filing in the parent case, U.S. Patent Application No. 09/983,471, filed October 24, 2001.

Respectfully submitted,

SMITH, GAMBRELL & RUSSELL, LLP



By: Robert G. Weilacher, Reg. No. 20,531

Dated: October 27, 2003  
Suite 3100, Promenade II  
1230 Peachtree Street, N.E.  
Atlanta, Georgia 30309-3592  
Ph: (404) 815-3593  
Fax: (404) 685-6893